



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 21, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG830647417

LABORATORY GROWN DIAMOND

SQUARE EMERALD CUT

8.78 X 8.63 X 5.95 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.10 CARATS

F

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

 LG830647417

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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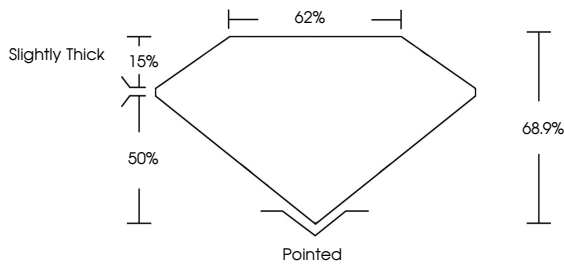
EXCELLENT

NONE

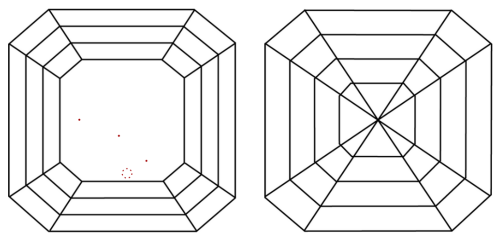
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PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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SQUARE EMERALD CUT

8.78 X 8.63 X 5.95 MM

Color Grade

Clarity Grade

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

4.10 CARATS

F

VS 1

68.9%

62%

Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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